



RYUKA.006AUS

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant	:	Masaki Takakuwa et al.	)	Group Art Unit 2881
			)	
Appl. No.	:	10/624,423	)	
			)	
Filed	:	July 21, 2003	)	
			)	
For	:	ELECTRON BEAM EXPOSURE	)	
		APPARATUS AND ELECTRON	)	
		BEAM MEASUREMENT MODULE	)	
			)	
Examiner	:	Paul M. Gurzo	)	
			)	

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ELECTION & AMENDMENT

Hon. Commissioner  
of Patents and Trademarks  
Alexandria, VA 22313-1450

Dear Sir:

ELECTION:

This election is submitted in response to the office action mailed August 23, 2005 for the above-identified patent application.

The applicant elects, without prejudice, the invention group 2 directed to Figure 4 for further prosecution of this case. Claims 8-13 are readable on the invention group 2.